Electronic Supplementary Information

Ultrafast carrier dynamics in vanadium doped MoS₂ alloys

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Determination of the free electron density (n_f)

The value of $n_{\rm f}$ was calculated using Debye-Huckel screening length (L_{sc}) relation

$$n_f = \frac{K_p k_B T}{2e^2 L_{sc}}$$

considering the parameter values $L_{sc} = a_B = 0.6 \text{ nm}^1$, $K_p = \varepsilon x \varepsilon_o = 2.85 \text{ x } 8.54 \text{ x} 10^{-12} \text{ } \text{ C}^2/\text{N-m}^2$, e=1.6x10⁻¹⁹ C, T=300 K, and k_B=1.38x10⁻²³ J/K.



Fig. S1 X-ray photoemission spectra (XPS) of MH-V-MoS₂ corresponding to (c) molybdenum (Mo), (d) sulphur (S) and (e) vanadium (V).



Fig. S2 (a) Linear reflection spectra and (b) photoluminescence (PL) spectra of pristine and Vdoped MoS₂ samples.



Fig. S3 (a-b) Fitting results for TA kinetics measured at different pump fluences in H-V- MoS₂. Pump and probe wavelengths used during measurements were 480 and 660 nm, respectively. (c) TA kinetics of H-V- MoS₂ measured up to 9 ns with 660 nm probe and 480 nm pump lights.

Table S1. Atomic percentage of Mo, V and S	in H -V-MoS ₂ alloy obtained from	XPS spectra.
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Element- orbital	Peak BE (eV)	FWHM (eV)	Area (P)	Atomic %
			CPS.eV	
S-2p	162.12	1.09	7706.58	64.29
Mo-3d	229.16	1.12	21630.97	32.09
V-2p	513.58	1.08	1691.38	3.62

Table S2. Atomic percentage of Mo, V and S in MH-V-MoS₂ alloy obtained through XPS measurements.

Element -orbital	Peak BE (eV)	FWHM (eV)	Area (P)	Atomic %
			CPS.eV	
S-2p	161.89	1.16	2374.60	60.95
Mo- 3d	228.90	1.02	6941.79	31.69
V-2p	516.63	2.27	1115.12	7.36

Table S3. Fitting results of TA kinetics for A-exciton of ML MoS_2 measured with different pump energy.

Pump energy (eV)	$\boldsymbol{\tau}_1 \operatorname{ps} (A_1 \%)$	$\boldsymbol{\tau}_2 \operatorname{ps}(A_2\%)$	$\boldsymbol{\tau}_3^* \operatorname{ps}(A_3 \%)$
3.02	0.20±0.01 (73)	7.50±0.69 (19)	500 (8)
2.58	0.19±0.01 (71)	8.00±0.57 (15)	500 (14)
2.33	0.20±0.01 (67)	7.16±0.35 (22)	500 (11)
2.00	0.21±0.01(60)	16.32±1.12 (23)	500 (17)

* The value of $\boldsymbol{\tau}_3$ was kept constant during fitting

Table S4. Fitting results of TA kinetics at A' band of L-V-MoS₂ measured with different pump energy.

Pump energy (eV)	$\boldsymbol{\tau}_1 \operatorname{ps} (A_1 \%)$	$\boldsymbol{\tau}_2 \operatorname{ps} (A_2 \%)$	$\tau_3^* \text{ ps} (A_3 \%)$
3.02	0.18±0.01 (56)	8.60±0.69 (21)	1000 (23)
2.58	0.25±0.02 (46)	9.50±0.91 (24)	1000 (30)
2.33	0.23 ±0.02 (37)	8.30±0.87 (25)	1000 (38)
2.00	0.25±0.09 (31)	10.69±2.09 (31)	1000 (38)

* The value of $\boldsymbol{\tau}_3$ was kept constant during fitting

Pump	Decay-1 (ps)	Decay-2* (ps)	Rise (ps)
fluence	(#FC %)	(FC %)	(FC %)
$(\mu J/cm^2)$			
8.8	2.21±0.23 (83)	1000 (17)	-
12.4	1.84±0.11 (85)	1000 (15)	-
20.7	2.11± 0.14 (93)	1000(7)	-
24.0	1.49±0.07 (99)	1000(1)	-
29.1	1.56±0.07 (100)	-	17.44±7.77 (100)
37.6	1.29±0.03 (100)	-	41.37±7.97 (100)
44.5	1.12±0.02 (100)	-	52.54±6.38 (100)

Table S5. Results of the fitting of TA kinetics of H-V-MoS_2 measured at 665 nm with a pump wavelength 480 nm.

* The value of decay-2 was kept constant during fitting

[#]FC: fractional contribution

References

1 Y. Yu, G. Li and L. Cao, *arXiv*, 2020, 2007.11509.